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Applicant

Chih-Ming Ke et al.

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Group Art Unit

**INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION.**

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(Use several sheets if necessary)

## U. S. PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	TITLE	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
SN	5 7 9 8 8 3 7 8	25/98	Aspnes et al.	356	369	7/11/97
SN	6 3 0 4 3 2 6	10/16/01	Aspnes et al.	356	369	2/8/99
SN	6 4 1 1 3 8 5 6	25/02	Aspnes et al.	356	369	6/21/01
SN	6 4 1 7 9 2 1 7	9/02	Rosencwaig et al.	356	369	6/13/01
SN	6 0 5 7 9 2 8 5	2/00	Li et al.	356	445	6/15/99

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


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